



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 2, 2025  
IGI Report Number **LG673415753**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR MODIFIED BRILLIANT**  
Measurements **8.08 X 5.54 X 3.81 MM**

GRADING RESULTS

Carat Weight **1.52 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**

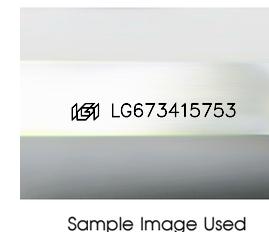
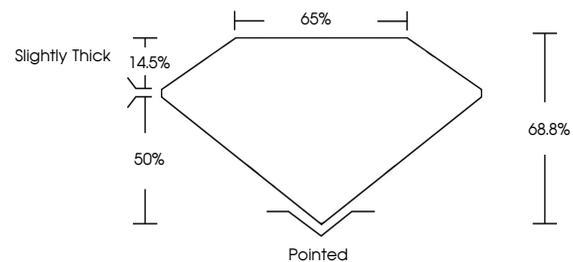
ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**

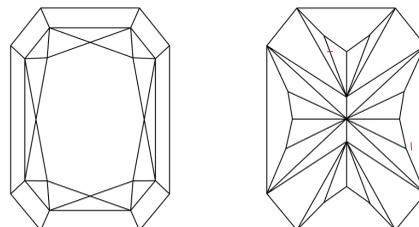
Inscription(s) **IGI LG673415753**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

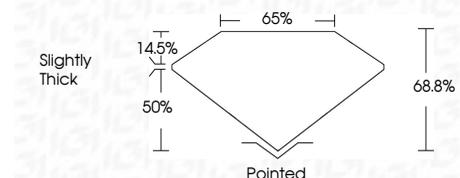
D E F G H I J Faint Very Light Light

CLARITY

IF WS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>  
Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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CUT **CORNERED RECT. MODIFIED BRILLIANT**  
8.08 X 5.54 X 3.81 MM  
Carat Weight **1.52 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**  
Depth **68.8%**  
Table **14.5%**  
Girdle **Slightly Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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Type IIa